



Gp/2882

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:  
Gueorgui Gueorguiev

) Group Art Unit  
) 2882

Serial No.: 09/709896  
Filed: 11/13/00  
For: Irradiation System and Method  
Using X-ray Reflector and  
Gamma Ray Reflector

) Examiner:  
) Elizabeth M. Gemmell  
)  
)  
)

Assistant Commissioner for Patents  
Washington, D.C. 20231

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MAR 13 2002

Technology Center 2100

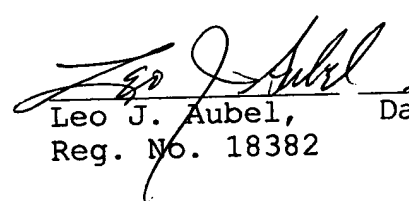
Communication

Dear Sir:

The subject application has been allowed.

A copy of an "Assignment of Application" form executed on  
30 July 2001 by the inventor to Rad Source Technologies Inc.,  
assignee of Largo Florida is enclosed for the record.

Respectfully submitted,

 2/14/02  
Leo J. Aubel, Date  
Reg. No. 18382

Leo J. Aubel P.C.  
111 Rivershire Lane  
Lincolnshire, IL 60069  
Phone 847-634-8923  
Fax 847-634-8985